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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Application Number	10/044,899
		Filing Date	01-09-2002
		First Named Inventor	Nicholas L. Abbott
		Group Art Unit	1639
		Examiner Name	Lundgren, Jeffrey S.
Sheet	1	of	1
		Attorney Docket Number	061818-5002-US04

U.S. PATENT DOCUMENTS			
Exr Initials	U.S. Patent Document Number	Kind Code (if known)	Name of Inventor or Applicant of Cited Document
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FOREIGN PATENT DOCUMENTS					
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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS		
Exr Initials	Include Name of Author (in CAPITAL LETTERS), title of the article (where appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ₁
	Motohiro, T.; Taga, Y. Sputter-Deposited SiO ₂ Films for Liquid Crystal Alignment, <i>Thin Solid Films</i> , 1990, 185 (1), pp 137-144.	
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DB2/22240611.2

Examiner Signature	Date Considered
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¹ EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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